From the Editor

X-ray Microscopy in your Lab

Using X rays to produce magnified images of objects has been a goal for 150 years. Ever since Ernst Abbe declared in 1873 that light microscope resolution was limited by the wavelength of light, the search was on for a microscopy medium with a wavelength shorter than visible light (< 500 nm). When Roentgen discovered X rays in 1895, it was thought that the new medium may have been found. Soon it was clear, however, that it was not easy to construct a physical lens for X rays because the rays penetrated all lens construction materials. X-ray "radiography images" of a few times magnification were possible but only as projection images, formed as X rays from millimeter-sized sources traveled in straight lines through the specimen to be captured on film. Unfortunately, even in the best cases, useful magnification was limited by the relatively large "point source" of X rays and the large grain size of X-ray film (both about 0.1–1.0 mm).

Thus, the accelerated electron, with its much smaller wavelength, became the first medium that allowed a better microscope. In 1934 Ruska demonstrated an electron microscope with resolving power and magnification greater than the light microscope. But the search continued for a way to produce higher resolution X-ray micrographs. Several X-ray microscopes were made in the 1950s, including Newberry's commercial instrument manufactured by General Electric. While useful images were demonstrated at conferences, interest in the technique waned until the advent of synchrotron X-ray sources and computed tomography fostered the development of many new methods and devices. While today synchrotron facilities produce high-quality X-ray micrographs, it has always been a goal to use X-ray microscopy in the typical research lab to complement other analytical methods.

Over the last four decades, there has been continual improvement in smaller laboratory-based sources. High-brightness rotating anodes and, soon, liquid-metal, jet-based laboratory sources provide higher X-ray fluxes, permitting dynamic *in situ* radiographic studies that formerly were the purview of synchrotrons. Detectors also have improved with smaller pixel sizes (improving resolution) and faster detector read-out electronics. Three-dimensional tomographic images reveal internal specimen morphology at near-SEM resolution non-destructively. Projection views of internal specimen features, even at modest resolution, can be of great utility in selecting specimens, preparing specimens, and locating regions of interest for high resolution SEM or TEM.

The articles in this issue show that powerful X-ray microscopy now can be accomplished with laboratory-based systems. Thus, the technique now complements both light microscopy and electron microscopy in the core microscopy facility. I thank Editorial Board member Brian M. Patterson for assistance with this editorial.

Editor-in-Chief Charles Lyman

Publication Objective: to provide information of interest to microscopists.

Microscopy Today is a controlled-circulation trade magazine owned by the Microscopy Society of America that is published six times a year in the odd months. Editorial coverage spans all microscopy techniques including light microscopy, scanning probe microscopy, electron microscopy, ion-beam techniques, and the wide range of microanalytical methods. Readers and authors come from both the life sciences and the physical sciences. The typical length of an article is about 2,000 words plus figures and tables; feature articles are longer. Interested authors should consult "Instructions for Contributors" on the Microscopy Today website: www.microscopy-today.com.

ISSN 1551-9295

Disclaimer

The Microscopy Society of America and the editors cannot be held responsible for opinions, errors, or for any consequences arising from the use of information contained in *Microscopy Today*. The appearance of advertising in *Microscopy Today* does not constitute an endorsement or approval by the Microscopy Society of America of any claims or information found in the advertisements. By submitting a manuscript to *Microscopy Today*, the author warrants that the article is original or that the author has written permission to use copyrighted material published elsewhere. While the contents of this magazine are believed to be accurate at press time, neither the Microscopy Society of America, the editors, nor the authors can accept legal responsibility for errors or omissions.

© Copyright 2012 by the Microscopy Society of America. All rights reserved.



Editorial Staff

Charles E. Lyman, Editor-in-Chief charles.lyman@lehigh.edu (610) 758-4249

Gennifer Levey, Production Manager glevey@meridianartproduction.com (212) 780-0315

Ron Anderson, Executive Editor microscopytoday@tampabay.rr.com

Phil Oshel, Technical Editor oshellpe@cmich.edu

Stephen Carmichael, Columnist carmichael.stephen@mayo.edu

Michael Davidson, Pioneers Editor davidson@magnet.fsu.edu

Steven Barlow, *Education Editor* sbarlow@sunstroke.sdsu.edu

Thomas E. Phillips, Consulting Editor phillipst@missouri.edu

E. Ann Ellis, *Microscopy 101 Editor* eann.ellis@worldnet.att.net

Paul Webster, Calendar Editor pwebster@usc.edu

John Shields, Humor Editor jpshield@uga.edu

Thomas Kelly, Chief Awards Judge Thomas.kelly@ametek.com

Advertising Sales

M.J. Mrvica Associates, Inc. 2 West Taunton Avenue, Berlin, NJ 08009 mjmrvica@mrvica.com (856) 768-9360

Amy Reuter, Account Manager areuter@mrvica.com

Magazine website:

http://www.microscopy-today.com Free subscriptions are available

Publisher

Cambridge University Press 32 Avenue of the Americas New York, NY 10013-2473 (212) 337-5000

Circulation: 18,000

Editorial Board

Arlan Benscoter, Lehigh University John Bozzola, Southern Illinois University Peter Crozier, Arizona State University Vinayak Dravid, Northwestern University Joseph Goldstein, University of Massachusetts David Grubb, Cornell University Bryan Huey, University of Connecticut John Mackenzie, North Carolina State Univ. Paul Maddox, University of Montreal Ania Majewska, U. Rochester Med School Greg Meeker, U.S. Geological Survey Joseph Michael, Sandia National Labs Caroline Miller, Indiana University Brian M. Patterson, Los Alamos National Lab Robert Price, University of South Carolina John Reffner, John Jay College, SUNY Ian Robertson, University of Illinois Phillip Russell, Appalachian State University Glenn Shipley, Citizen Microscopist Robert Simmons, Georgia State University Paul Voyles, University of Wisconsin Simon Watkins, University of Pittsburgh Cynthia Zeissler, Nat. Inst. of Sci. and Tech. (NIST)